

03500.014529.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Prior Examiner: C. L. Novacek
Yukiko IWASAKI, et al.)	
	:	Prior Group Art Unit: 2822
Application No.: Unassigned (Divisional)	
of Appln. No. 09/586,887,	:	
filed June 5, 2000))	
	:	
Filed: September 24, 2003)	
(filed concurrently herewith)	:	
)	
For: PROCESS FOR PRODUCING	:	September 24, 2003
SEMICONDUCTOR MEMBER,)	
PROCESS FOR PRODUCING	:	
SOLAR CELL, AND ANODIZING)	
APPARATUS	:	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. §119 based upon the following Japanese

Priority Applications:

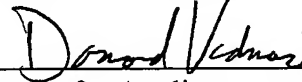
11-161110, filed June 8, 1999; and

11-161111, filed June 8, 1999.

The certified copies of the priority documents were previously filed in parent Application No. 09/586,887. Applicants respectfully request acknowledgment of this claim and of receipt of the certified copies of the priority documents with the next communication from the Office.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Damond E. Vadnais", is written over a horizontal line.

Attorney for Applicants
Damond E. Vadnais
Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
DEV:cmv
DC_MAIN 144711 v 1